



15 AF
**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITE PROCEDURE
EXAMINING GROUP 4176**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 4073

Chiaki KOBAYASHI et al.

Group Art Unit: 4176

Application No.: 10/507,366

Examiner: Jesse Y. MIYOSHI

Filed: May 18, 2005

Attorney Docket No.: 103213-00099

For: PRESSURE SENSOR

RESPONSE UNDER 37 C.F.R § 1.116

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

March 18, 2008

Sir:

In reply to the outstanding Office Action dated December 18, 2007, please consider the remarks as shown on the following pages:

Remarks begin on page 2.

Conclusion begins on page 7.